Telink Semiconductor (Shanghai) Co., Ltd.

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FCC Confidential Authorization

Date: 2023-04-06

FEDERAL COMMUNICATIONS COMMISSIONS Authorization and Evaluation Division 7435 Oakland Mills Road Columbia, MD 21046

Subject: Confidentiality Request regarding application for certification of

FCC ID: OEOTLSR9528ADK88D

In accordance with Sections 0.457 and 0.459 of the Commission's Rules, (Telink Semiconductor (Shanghai) Co., Ltd.) hereby requests long-term confidential treatment of information accompanying this application as outlined below:

- Block Diagram
- Schematics
- Operation Description

King Li

The above materials contain proprietary and confidential information not customarily released to the public. The public disclosure of these materials provides unjustified benefits to its competitors in the market.

Sincerely,

Signature:

Printed Name: Xiang Li

Title: Manager